



Giant enhancement of ultraviolet near-band-edge emission from a wide-bandgap oxide with dipole-forbidden bandgap transition



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ABSTRACT

We report giant enhancement of recovered ultraviolet near-band-edge emission from SnO₂ thin films with dipole-forbidden bandgap transition via Ag-doping and surface plasmon coupling. It is found that a recovering near-band-edge emission in the range of 361–375 nm in a low-concentration Ag-doped SnO₂ film, suggesting that dipole-forbidden transition rule of SnO₂ is broken. First-principles electronic structure calculations indicate that the breaking of the dipole-forbidden transition rule is derived from the acceptor of Ag substituting Sn in SnO₂. 30-fold enhancement of ultraviolet near-band-edge emission from the Ag-doped SnO₂ film is observed by modifying film surface using Ag nanoparticles. The giant enhancement of ultraviolet emission is ascribed to surface plasmon coupling between Ag-doped SnO₂ and Ag nanoparticles. Our results suggest that Ag doping and Ag nanoparticles surface modification in SnO₂ films play important roles in recovering and enhancing ultraviolet emission of SnO₂ with dipole-forbidden bandgap transition.

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1. Introduction

Wide-bandgap oxides have attracted much attention due to their rich functionalities and technological applications [1–11]. Among these oxides, tin dioxide (SnO₂), as a wide bandgap semiconductor, has been applied in the fields of transparent conducting thin films, solar cells, gas sensors, catalysis and so on [12–18]. Although bulk SnO₂ has a wide direct bandgap of ~3.6 eV, it cannot efficiently emit ultraviolet (UV) light due to the dipole-forbidden nature of its band edge quantum states [19], which has hindered its potential use in optoelectronic applications, such as photodetectors and light-emitting diodes (LEDs). In our previous work, to recover the optical activity of SnO₂ and realize the UV near-band-edge (NBE) emission, we utilized nanoengineering and doping engineering to modify SnO₂ electronic structure so that the

dipole-forbidden rule can be broken and we also demonstrated SnO₂-based UV LEDs [12,13]. However, the intensity of UV emission from the SnO₂ layer is still weak. Recent decade, Surface plasmons (SPs) have been widely used to improve the emission efficiency of light emitting materials and devices [20]. For instance, Okamoto. *et al* reported the SPs enhanced light emitters based on InGaN quantum wells [21]. To achieve enhancement of UV emission induced by SPs, one of key factors is the energy match. The exciton energy can be rapidly transferred to plasmon excitation when the large frequency overlaps between SPs electric field and semiconductors [22,23]. Therefore, the key to enhance the UV emission is to choose the appropriate metal. Grontijo *et al.* reported that the first example of resonance coupling of the semiconductor spontaneous emission into SPs [24]. For metal Ag, the bulk plasmon energy is 3.7 eV and the SPs energy is somewhat lower, depending on the retroactive index of the adjacent dielectric [25–27]. The result indicates that this energy range is fortunate since the SnO₂ can be resonant with Ag SPs. Hence, the feature of the Ag surface plasmon resonance (SPR) effect can be also applied to the field of SnO₂ thin films to enhance the UV emission. To the best of our knowledge,

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there has been no report on enhancement of the UV emission in SnO₂ thin films.

In this paper, we demonstrate the recovering UV emission in the SnO₂ thin film with dipole-forbidden bandgap transition via Ag-doping and the UV giant enhancement induced by SPR effect in the Ag-doped SnO₂ film with surface modification using Ag nanoparticles (SnO₂:Ag/Ag nanoparticles hybrid films).

2. Experimental process and first-principles calculations detail

The SnO₂:Ag/Ag nanoparticles hybrid films were synthesized on quartz substrates using the sol-gel method. Fig. 1 shows the schematic synthesization process of the SnO₂:Ag/Ag nanoparticles hybrid films. An undoped SnO₂ layer was first deposited on quartz substrates by sol-gel method. The detailed synthesization method of the undoped SnO₂ layer can be found in our previous work [13]. Then a layer of silver nitrate (AgNO₃) sol was spin-coating on the undoped SnO₂ layer. Finally, the films were annealed in a horizontal quartz-tube furnace exposed in the air at 500 °C for 1 h to obtain the SnO₂:Ag/Ag nanoparticles hybrid films. The Ag concentration in the hybrid film can be controlled by changing AgNO₃ concentration in the sol. Four samples with various Ag concentration were obtained and are denoted as T0, T1, T2 and T3, corresponding to Ag concentration of 0, 0.5 at.%, 1 at.% and 2 at.%, respectively.

X-ray diffraction (XRD) measurements were carried out for structural characterization using a powder diffract meter with a Cu K α radiation. The optical absorption measurements were performed using a UV–vis–near-IR spectrophotometer. The morphologies of the samples were characterized by using scanning electron microscope (SEM). A transmission electron microscope (TEM) was used to examine the crystalline structure of the samples. The photoluminescence (PL) measurements were performed using a He–Cd laser with a 325-nm line as the excitation source. The chemical states of Ag in the hybrid films were detected using x-ray photoelectron spectroscopy (XPS) with Al K α ($h\nu = 1486.6$ eV) x-ray radiation source.

First-principles calculations were performed using the VASP code with the projector augmented wave (PAW) method within the frame of density function theory (DFT) [28–31]. All calculations were carried out using the hybrid functional as proposed by Heyd,

Scuseria, and Ernzerhof (HSE) [32,33]. The *d* electrons of Sn and Ag atoms were treated as valence electrons. A 72-atom $2 \times 2 \times 3$ SnO₂ supercell with the rutile structure was constructed. To simulate Ag doping in SnO₂, a Sn atom is replaced by an Ag atom in the supercell. The cutoff energy for the plane-wave basis set is 400 eV. In the calculations, all the atoms are allowed to relax until the Hellmann–Feynman forces acting on them become less than 0.01 eV/Å. Although the calculated bandgap of pure SnO₂ is underestimated within HSE framework (2.77 eV), i.e. smaller than the experimental value [12], it does not affect our discussion on the results.

3. Results and discussion

Fig. 2a shows the XRD patterns of all samples grown on quartz substrates. It is found that all the thin films are polycrystalline with rutile structure. For the SnO₂:Ag film with 0.5 at.% Ag concentration (sample T1), no diffraction peak of metal Ag or Ag related phase is observed, indicating that the Ag atoms are doped into SnO₂. As increasing Ag concentration (>0.5 at.%, T2 and T3), the diffraction peaks of metallic Ag are observed, implying existence of metal Ag phase in the films. In order to further check the existence of metal Ag in the SnO₂ films, XPS measurements were carried out. Fig. 2b shows the Ag 3d XPS spectra of the 2.0 at.% Ag-doped SnO₂ film (T3) before and after its surface was etched by Ar ion. Before etching, there is a strong peak and a weak shoulder for both Ag 3d_{5/2} and 3d_{3/2}, respectively. The strong peak is attributed to Ag⁺ and the weak shoulder to Ag⁰ [34,35]. The fitting peaks are located at 367.9, 368.8, 373.9 and 374.8 eV, which is corresponding to Ag⁺ 3d_{5/2}, Ag⁰ 3d_{5/2}, Ag⁺ 3d_{3/2} and Ag⁰ 3d_{3/2}, respectively. After etching, the intensity of the shoulder is significantly decreases, indicating that metal Ag composition is reduced. The XPS results suggest that the Ag⁺ ions, as acceptor dopants, are derived from the Sn sites in SnO₂ and the metal Ag⁰ mainly exists on the surface of the SnO₂ films. Fig. 2c shows the SEM image of the 2.0 at.% Ag-doped SnO₂ thin films. It is observed that the ball-shaped Ag particles are scattered on the surface of SnO₂ thin films. The grain sizes of Ag particles are in the range of 300–500 nm, indicating that the size of Ag particles is in nanoscales. A cross-sectional TEM image of the Ag-doped SnO₂ thin films with Ag concentration of 2 at.% is shown in Fig. 2d. A sharp interface between the crystalline film and amorphous substrate is observed.

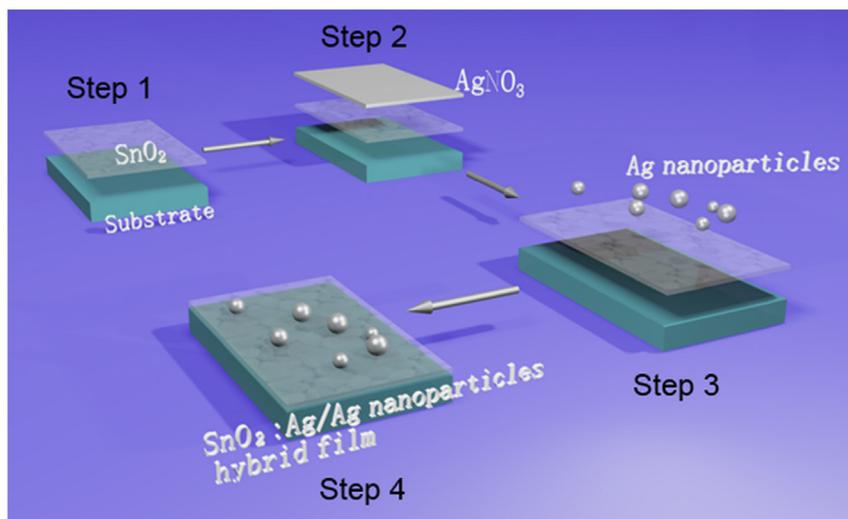


Fig. 1. Schematic fabrication process of the Ag-doped SnO₂ hybrid thin films with Ag nanoparticles surface modification.

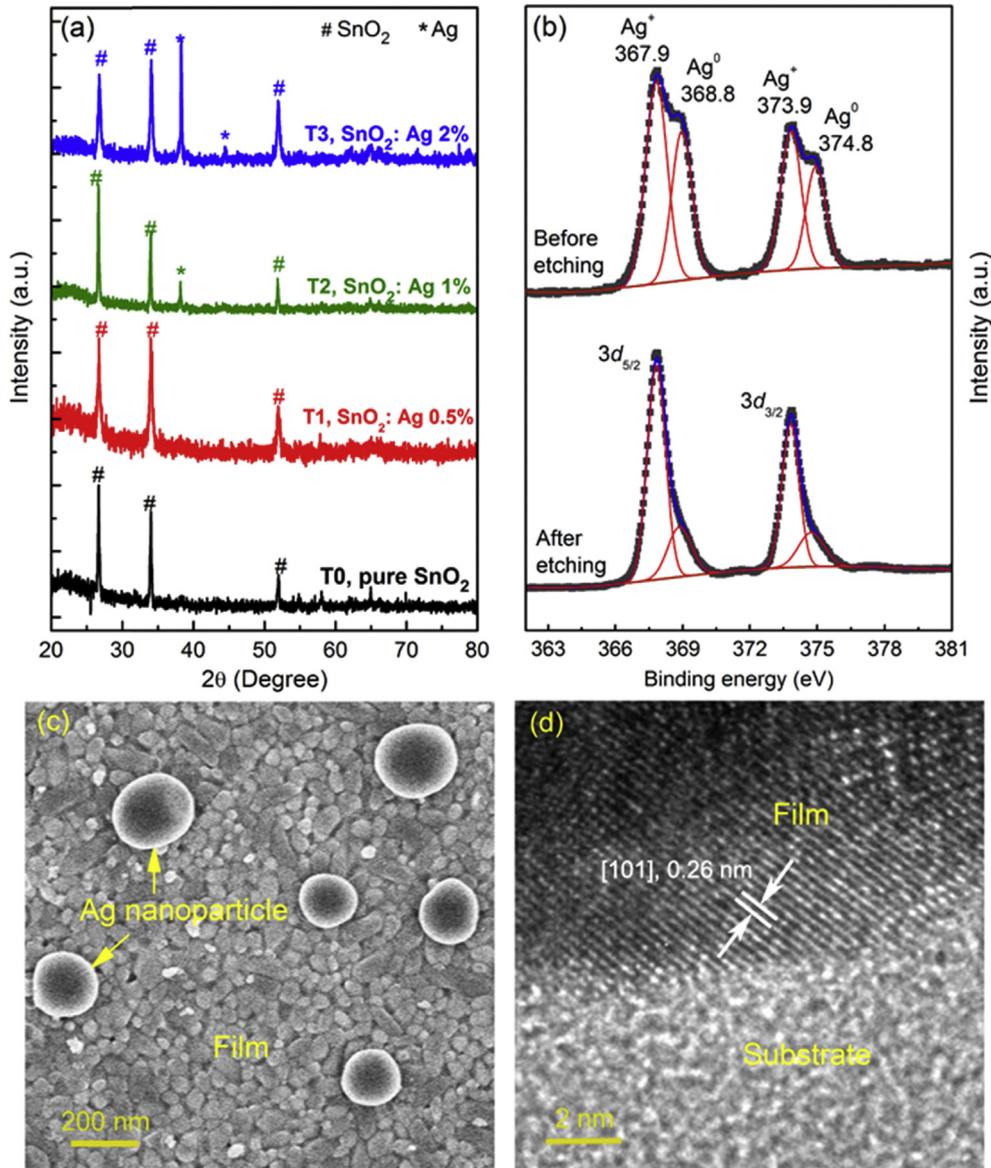


Fig. 2. Structural, chemical state and surface morphological characterizations of the SnO₂:Ag/Ag nanoparticles hybrid thin films. (a) XRD patterns of the undoped and Ag-doped SnO₂ films with various Ag concentration grown on quartz substrates. (b) Ag 3d XPS spectra of the Ag-doped SnO₂ films with Ag concentration of 2 at.% (sample T3). (c) Surface SEM image of the Ag-doped SnO₂ thin films with Ag concentration of 2 at.%. (d) Cross-sectional TEM image of the Ag-doped SnO₂ thin films with Ag concentration of 2 at.%.

To examine the effect of Ag doping and Ag nanoparticle on PL properties of SnO₂ films, we performed room temperature PL spectra for all samples grown on quartz substrates, as shown in Fig. 3a. For the undoped SnO₂ (T0), only one visible light emission band centered at ~ 540 nm was observed, which is attributed to the defect states related to the presence of structural defect like oxygen vacancies [36]. No NBE emission in the UV region was observed due to the dipole-forbidden rule. Compared with the undoped SnO₂ thin film, a dominant UV emission peak centered at 375 nm was observed for the 0.5 at.% Ag-doped SnO₂ film (T1), indicating that Ag doping can break the dipole-forbidden rule to realize UV light emission. Moreover, the UV emission intensity of the 1.0 at.% (T2) and 2.0 at.% (T3) Ag-doped SnO₂ films significantly increase. The enhancement ratio of the UV emission of the 2.0 at.% Ag-doped SnO₂ was almost 30-fold higher than that of the 0.5 at.% Ag-doped SnO₂. To see the change of PL intensity clearly, a logarithmic scale is adopted for the PL spectra, as shown in the inset of Fig. 3a. It is obviously that the UV emission enhancement

is attributed to the interaction between the radiative recombination in SnO₂:Ag and SPs arising from Ag nanoparticles interfaces. The UV emission enhancement can be explained as follows. Electron-hole pairs are first generated in Ag-doped SnO₂ films by He–Cd laser. The emission energy can transfer to the SPs when the gap energy of SnO₂ is comparable to the electron vibration energy of SPs at the metal-Ag/SnO₂:Ag interface. Then the energy from metal/semiconductor SPs should be effectively transferred to the opposite air/metal surface SPs. Finally, the energy can be extracted as light by scattering of SPs at air/metal surface due to the surface roughness.

Fig. 3b shows the plot of $(\alpha h\nu)$ [2] vs. the photon energy $h\nu$ of the undoped and Ag-doped SnO₂ thin films. The optical bandgap of the undoped SnO₂ film is determined to be ~3.9 eV, in agreement with the values of 3.6–3.9 eV from the previous reports [12,13]. Meanwhile, the optical bandgap of the undoped SnO₂ film is much larger than the fundamental bandgap of 3.3–3.4 eV, indicating the nature of dipole-forbidden bandgap transition. As the Ag concentration

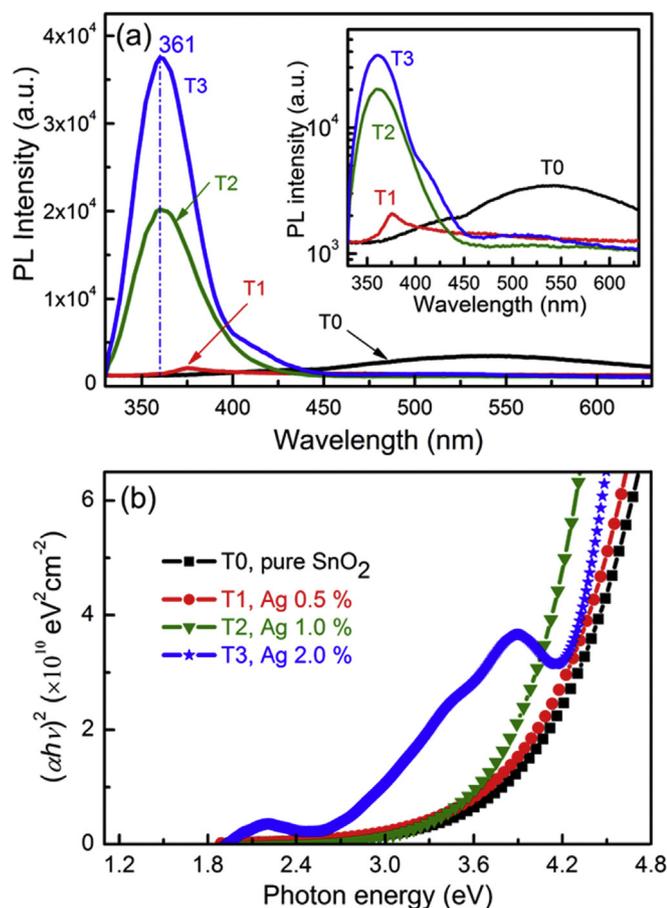


Fig. 3. Room temperature (a) PL and (b) optical absorption spectra of the undoped and Ag-doped SnO₂ thin films grown on quartz substrates. The inset in (a) shows a logarithmic scale of the PL spectra for clear demonstrating the weak emission.

increases, the optical bandgap shows a significant redshift, which is due to the acceptor states in the bandgap induced by Ag doping [37]. Therefore, the defect states relevant to Ag impurities play key role in breaking the dipole-forbidden rule. Additionally, it should be noted that a strong band-tail absorption band, smaller the optical bandgap of undoped SnO₂, is observed in the absorption spectra of the 2.0% at.% Ag-doped SnO₂ films (T3). The strong band-tail absorption is attributed to the SPR absorption of Ag nanoparticles on the film surface, which is consistent with the PL result.

Finally, to better understand the recovering UV emission in Ag-doped SnO₂, we performed first-principles calculations within the frame of DFT. Fig. 4a and b shows the calculated energy band structures of the perfect and Ag-doped SnO₂ systems, respectively. The calculated fundamental bandgap of the perfect SnO₂ systems are 2.77 eV. For the Ag-doped SnO₂ system, impurity states relevant to Ag substituting Sn is found in the gap. To better understand the transition, optical absorption spectra of the perfect and Ag-doped SnO₂ systems were calculated, as shown in Fig. 4c. To simulate the optical properties of the polycrystalline SnO₂, the polarized absorption from x-, y- and z-direction is averaged. For the perfect SnO₂, the onset of the optical absorption edge is much higher than the calculated fundamental bandgap of 2.77 eV, indicating that the band edge transition is forbidden in perfect SnO₂. For the Ag-doped SnO₂, the optical absorption edge significantly moves towards to low energy side and there exists a strong band-tail absorption near fundamental bandgap, in consistency with the results of the optical absorption spectra. The calculated results suggest that Ag doping

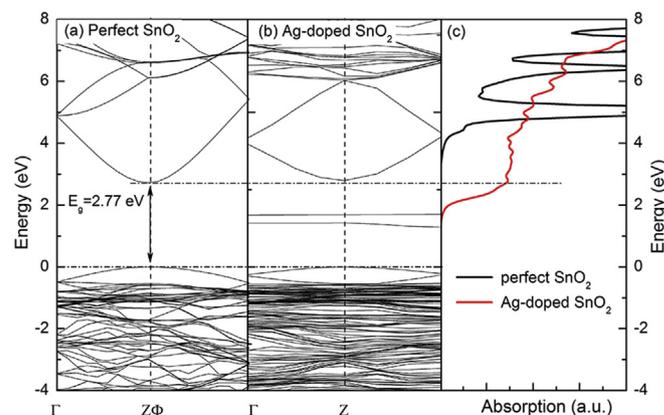


Fig. 4. Electronic structures of the perfect and Ag-doped SnO₂ from the first-principles calculations. Band structures of the (a) perfect and (b) Ag-doped SnO₂. (c) Polycrystalline optical absorption spectra of the perfect and Ag-doped SnO₂.

can break dipole-forbidden rule of SnO₂, well supporting our experimental results.

4. Conclusion

In summary, dipole-forbidden rule of SnO₂ can be broken via Ag doping and UV NBE emission also can be recovered via Ag doping. A giant enhancement of recovered UV emission in SnO₂:Ag/Ag nanoparticles hybrid film is observed, which is derived from SPs-mediated emission enhancement. Our findings may pave the way for the further development of high-efficiency SnO₂-based UV light-emitting diodes and laser diodes.

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